



Docket No.: 3430-0175P

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Young-Sang BYUN et al.

Application No.: 10/028,433

Confirmation No.: 4398

Filed: December 28, 2001

Art Unit: 2871

For: METHOD OF FORMING A LIQUID

Examiner: T. V. Duong

CRYSTAL LAYER USING INK JET SYSTEM

AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

MS AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Examiner's Office Action dated January 24, 2006, the period for response having been extended one (1) month to May 24, 2006, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes:

Amendments to the Claims; and

Remarks.